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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideo YOSHIDA, et al.  
Serial No. : 10/526,205  
Filed : March 1, 2005  
For : ANODIC OXIDATION METHOD, TITANIUM  
OXIDE FILM MANUFACTURING METHOD  
AND CATALYST CARRYING METHOD  
Group Art Unit : 1742  
Examiner : William T. Leader

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(Signature)

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P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is an Information Disclosure Citation together with  
copies of the documents referred to therein.

Respectfully submitted,

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